



**ELECTRONIC COPY**

LG779647951  
Report verification at igi.org



March 9, 2026  
IGI Report Number **LG779647951**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**  
Measurements **11.27 X 7.79 X 5.25 MM**  
**GRADING RESULTS**  
Carat Weight **3.95 CARATS**  
Color Grade **E**  
Clarity Grade **VVS 2**

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Shape and Cutting Style **CUT CORNERED RECTANGULAR  
MODIFIED BRILLIANT**  
Measurements **11.27 X 7.79 X 5.25 MM**

**GRADING RESULTS**

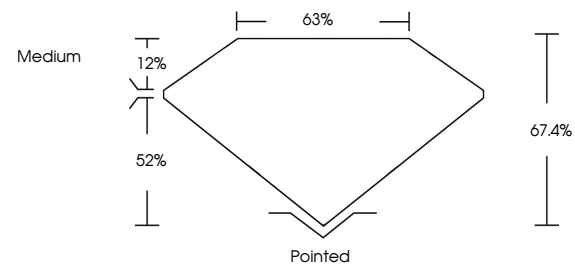
Carat Weight **3.95 CARATS**  
Color Grade **E**  
Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG779647951**

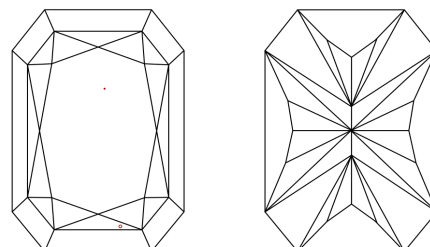
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

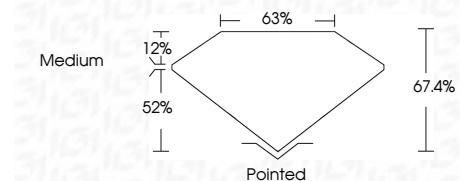
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG779647951**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
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**IGI**



March 9, 2026  
IGI Report No. LG779647951  
CUT CORNERED RECT. MODIFIED BRILLIANT  
3.95 CARATS E  
11.27 X 7.79 X 5.25 MM  
Color Grade VVS 2  
Depth 52.4%  
Table 63%  
Girdle Medium  
Culet Pointed  
Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscription(s) IGI LG779647951

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Type IIa